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Coupling spin defects in hexagonal boron nitride to titanium dioxide ring resonators†

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Spin-dependent optical transitions are attractive for a plethora of applications in quantum technologies. Here we report on utilization of high quality ring resonators fabricated from TiO₂ to enhance the emission from negatively charged boron vacancies (V_B⁻) in hexagonal Boron Nitride. We show that the emission from these defects can efficiently couple into the whispering gallery modes of the ring resonators. Optically coupled V_B⁻ showed photoluminescence contrast in optically detected magnetic resonance signals from the hybrid coupled devices. Our results demonstrate a practical method for integration of spin defects in 2D materials with dielectric resonators which is a promising platform for quantum technologies.

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Defects in hexagonal boron nitride (hBN) provide a test bed for the study of light–matter interactions and nanophotonics with two-dimensional materials at room temperature.^{1–5} Among them, optically addressable spin defects have recently gained momentum due to their relevant application in quantum sensing and quantum information technologies.^{6–10} Particularly, negatively charged boron vacancies (V_B⁻) is a spin 1 system which can be mapped out through optically detected magnetic resonance (ODMR) spectroscopy at room temperature.^{11–15} At zero field, the transitions between two spin states ($m_s = 0$ and $m_s = \pm 1$) in the ground state result in two resonances at ~ 3.4 and ~ 3.5 GHz in the ODMR signal.¹¹ Spin coherence of V_B⁻ has been exploited for high temporal and spatial resolution quantum sensing of temperature, strain, electric and magnetic fields.^{16–20} However, the photoluminescence emission from V_B⁻ spans in the NIR has no clear indication of zero phonon line (ZPL) even at cryogenic temperature, and the exact electronic level structure and emission dipole of V_B⁻ are yet to be understood. Just recently, coupling of the defects into high-quality cavities suggests the ZPL spectral location to be around 770 nm²¹ and excited state

spectroscopy of the defects revealed the spin states in the excited state.^{22–24} Moreover, the defect suffers from low intrinsic brightness and quantum efficiency. This limitation can be overcome by coupling the V_B⁻ to micro-resonators that enables efficient control over the emission properties as such presents an attractive platform for enhanced understanding and utilization of spin defects in van der Waals materials. Recent attempts have been made to couple V_B⁻ into bullseye²⁵ or plasmonic²⁶ structures which results in the enhancement of the emission. Among dielectric resonators supporting whispering gallery modes (WGMs), ring structures provide high-quality factors with low mode volume which theoretically enables achieving high emission enhancement and hence are attractive alternatives.^{27–30}

Here we realise a hybrid approach based on hBN flake as V_B⁻-hosting material on top of TiO₂ as a cavity platform. Since a high-quality cavity requires relatively large refractive index of ~ 2.5 and low optical loss in the wide wavelength range in the visible and IR, TiO₂ is an attractive material for the fabrication of waveguides and photonic resonators.^{31–34} The resonator is designed to support multimode WGMs with small free spectral range (FSR) in an attempt to enhance the broad emission of V_B⁻. Finally, the ODMR collected from the ring confirms the efficient coupling of spin defects in hBN into WGM modes of the TiO₂ ring resonator.

We developed a fabrication process to realize hBN/TiO₂ hybrid resonator and to demonstrate emission enhancement of spin defect by coupling to the WGMs. Given the layered nature, hBN could be readily integrated with other systems by the stacking strategy.³⁵ However, transferring hBN on cavity structures inevitably damages these fragile structures. Thus, to

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avoid this, a heterostructure was prepared prior to the fabrication process. The fabrication steps are described in detail in the Method section and schematically demonstrated in Fig. 1a. Briefly, a 200 nm of TiO_2 was first sputtered onto the Si substrate through ion-assisted deposition (IAD). The resulting film showed a smooth surface (average roughness of 0.9 nm) and high refractive index (2.3 at 800 nm). The characterization of the deposited TiO_2 film is provided in the ESI (Fig. SI-1†). hBN flakes were mechanically transferred from high quality bulk crystal onto the TiO_2 surface *via* scotch tape method. The sample was then annealed at 300 °C to remove the tape residual and maximize surface adhesion to form a stable heterostructure. At this temperature, TiO_2 phase transition and the associated change in the refractive index can be avoided to retain the low optical loss of the TiO_2 .³⁶ To increase accessibility of the defect to the cavity in hybrid approach, a thin flake (~20 nm) was picked for the fabrication. Therefore, the defect could be spatially closer to the cavity resulting in improved coupling efficiency since it minimizes optical loss in the hBN material. In order to realize suspended ring resonators, an array of wheel-like structures was subsequently patterned on the heterostructure using EBL technique followed by deposition of 50 nm Cr. After liftoff, the remaining Cr acting as a metal mask for the etching step. The pattern was then transferred into the heterostructure by reactive ion etching (RIE) method (Fig. 1a-i). Following the RIE step, pot-

assium hydroxide (KOH) aqueous solution was used to selectively etch the underlying Si substrate as shown in Fig. 1a-ii, resulting in a wheel-like hybrid resonator (Fig. 1a-iii). Finally, an angled ion beam was used to efficiently create V_B^- in the thin hBN flake. Transport of ions in matter (TRIM) calculation (Fig. SI-2a†) was performed to obtain the optimal condition for generation of defects within 20 nm of hBN using a nitrogen beam at an angle of 60° and fluences of $1 \times 10^{14} \text{ cm}^{-2}$.

Fig. 1b shows an optical microscope image of the patterned sample. The spatially precise lithography on the flake is directly visible by optical contrast showing boundaries between hBN flake and the TiO_2 substrate. The energy-dispersive X-ray spectroscopy (EDS) analysis after fabrication of the device also indicates the presence of hBN flake on top of the post-fabricated TiO_2 resonator (Fig. SI-3†). An Atomic Force Microscopy (AFM) image was scanned over the patterned area to confirm the thickness of patterned hBN as shown in Fig. 1c and Fig. SI-2b.† A detailed structure of the final hybrid resonator is shown in a high-resolution SEM image in Fig. 1d. Further SEM images of the resonators are presented in the ESI† indicating the quality of the resonator after fabrication (Fig. SI-4†).

Next, we characterized the coupling of V_B^- to the TiO_2 resonator using a confocal photoluminescence setup (Method section). The photoluminescence spectrum collected from the center of the ring (denoted as “off-ring”) is shown in Fig. 2a

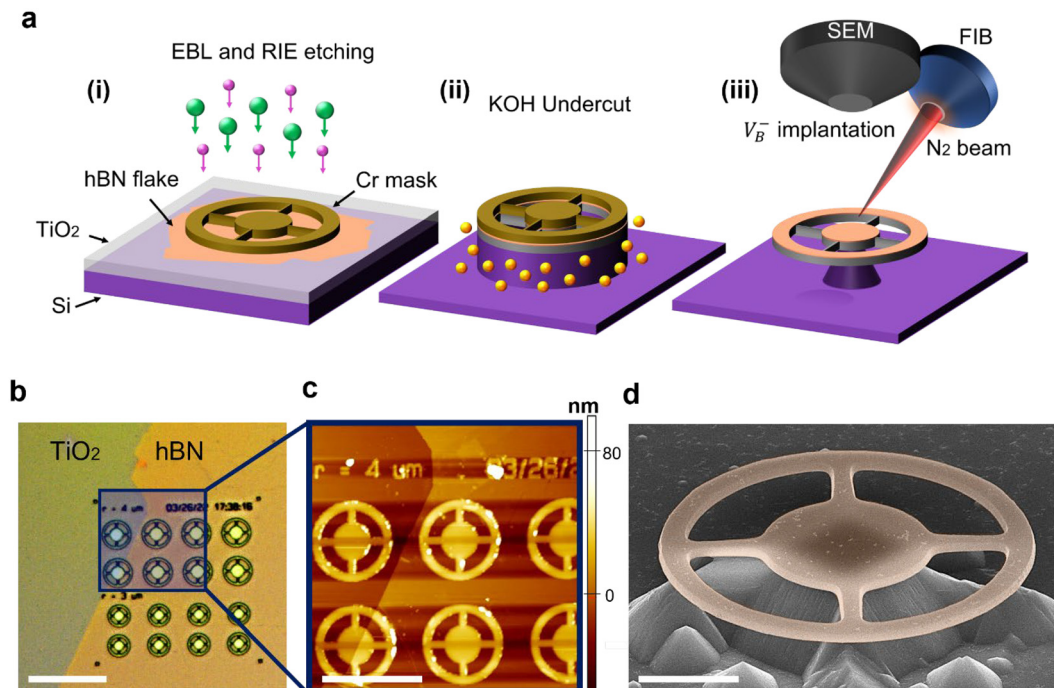


Fig. 1 Fabrication of hBN/ TiO_2 hybrid resonator. (a) Schematic representation of the fabrication process: (i) lithography step to pattern a Cr metal mask (brown steering-wheels) on hBN/ TiO_2 heterostructure and then transferring the mask into the heterostructure using ICP/RIE. Green and pink balls represent SF_6 , and Hydrogen species used in the latter step, respectively. (ii) Undercut of hBN/ TiO_2 hybrid resonator using 10% KOH aqueous solution. (iii) Generation of spin defects in hBN using angled Nitrogen focused ion beam (FIB). (b) Optical image of aligned EBL pattern on the hBN/ TiO_2 heterostructure. Scale bar: 25 μm . (c) AFM image of the patterned area. Scale bar: 10 μm . (d) 52° Tilted SEM image of the final hBN/ TiO_2 hybrid resonator. The false color shows the microring. Scale bar: 2 μm .

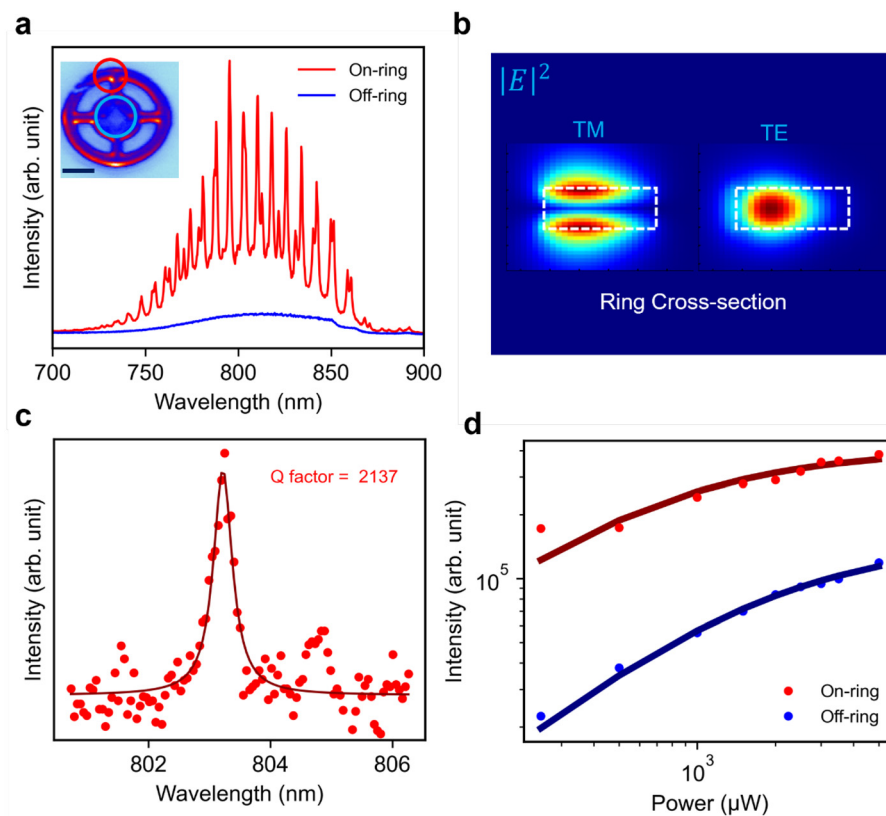


Fig. 2 Optical characterization of the microring resonator. (a) PL spectrum collected on (red) and off (blue) the ring. Inset – confocal scanning image of the corresponding hybrid resonator. Red and blue circles indicate collection spots corresponding to On and Off the ring, respectively. Scale bar: 2 μm . (b) Cross-section view of the FDTD simulation for the fundamental TE (transverse electric) and TM (transverse magnetic) modes, showing electric field distribution of the fundamental modes inside the resonator. The dash box outlines the TiO_2 cross-section view. (c) High-resolution spectra of the WGMs fitted by Lorentzian function yielding a quality factor of ~ 2100 for the fabricated ring resonator (d) integrated PL intensity of the signals collected on (red) and off (blue) the ring at increasing excitation power.

(blue spectra) and a relatively broad emission spectrum of V_B^- spanning from 750 to 850 nm was observed. In contrast, when V_B^- was excited on the ring (denoted as “on-ring”, red spectra), superimposed peaks resulting from the coupling of V_B^- emission to WGM of the rings were observed. Since the WGMs of the resonator cover entire V_B^- emission range with short FSR of ~ 7 nm, overall V_B^- signals were significantly enhanced compared to those of from uncoupled region. The coupled signals were collected from the scattering point (the bright spot indicated by red circle in the inset) where the photons partially outcoupled into the objective. Since light is well confined inside the cavity, the scattering points are necessary for the photon collection from top of the ring. The holding arms on the ring resonator can be used as scattering points to collect the modes from suspended rings. A pristine TiO_2 ring resonator without hBN was also measured as a reference (Fig. SI-5 \dagger). Normalized electric field distribution of Transverse Electric (TE) and Transverse Magnetic (TM) modes intensity was calculated using FDTD simulation as shown in Fig. 2b and Fig. SI-6. \dagger Electric field profile of the TE WGMs concentrated at the middle of the device whilst the TM field maxima confined at the top and bottom surface of the resonator as shown

in the cross-sectional views. The analysis of the individual peak from high resolution spectra is shown in Fig. 2c. A quality factor ($Q = \lambda/\Delta\lambda$) of 2137 was obtained after fitting the peak with Lorentzian function. Characterization of more devices are shown in Fig. SI-7a \dagger and a mean quality factor of 1800 was achieved in this study.

To further investigate the enhancement of the coupled signals, PL intensity was measured for both on-ring and off-ring emissions as a function of excitation power shown in Fig. 2d. The intensities for both cases, were integrated over the whole range of V_B^- emission, and the resulting data were fitted with the equation $I = (I_{\text{sat}}P)/(P + P_{\text{sat}})$, where I_{sat} is the saturation intensity, and P_{sat} is the saturation power. The saturation intensities of 0.405 MHz and 0.152 MHz and powers of 0.7 and 1.7 mW was obtained from the fit to the data (solid lines) for the on-ring and off-ring, respectively. These values yield the enhancement factor of about 3 and 7 in the saturated and unsaturated regimes.

In contrast, if each individual coupled signal is examined separately, the intensity of the coupled V_B^- emission is significantly higher than the uncoupled signal. For instance, we observed an enhancement factor of about 14 for the coupled signal at ~ 790 nm as shown in Fig. SI-7b. \dagger

Ultimately, to further characterize the hybrid devices, we employed ODMR spectroscopy to map spin transitions of the coupled V_B^- in local and non-local excitation configurations. The spin defect in hBN and its simplified electronic level structure is schematically depicted in Fig. 3a. The defect shows a triplet ground state (A_1^3) with a zero-field splitting of 3.48 GHz between the two spin states. We evaluate spin transitions from V_B^- that coupled to WGM in the local and non-local configurations. In the local configuration, the optical collection and excitation spots were overlapped, while at the non-local configuration, the excitation of the microscope was offset 180° on the ring away from the collection spot. The results and the schematic configuration of both scenarios are shown in Fig. 3b. The spectra recorded from non-local configuration is shown in Fig. 3b (purple) with similar features as the local excitation (green) indicating the efficient coupling of V_B^- into the TiO_2 ring resonator. We note that V_B^- can be excited by the guided laser in the ring as well. However, when the laser spot is fixed, no obvious emission on other part of the ring is detected, which highly suggest a low excitation efficiency in this scenario. Fig. 3c shows the corresponding ODMR signals for both excitation schemes. By sweeping a microwave from 3.2 to 3.8 GHz, a reduction in the photoluminescence of the V_B^- was detected at 3.4 and 3.5 GHz. These contrasts are the result of transitions from $m_s = 0$ to $m_s = \pm 1$ in the ground state which are driven by the microwave field (Fig. 3a). This verifies that V_B^- emits photons carrying spin information into the resonator and effectively coupled to the WGMs. The presence of spin transitions will confirm the boron vacancy defects are active in the hBN layer after fabrications. This is important for application of such structure utilizing spin properties of optically active spin defects in hBN. Both excitation scheme showed similar ODMR contrast with slight differences stemming from lower collection efficiency through non-local excitation.

In summary, we have developed a method for fabrication of a hBN/ TiO_2 resonators with high Quality factors exceeding ~ 2000 . Coupling of V_B^- to the WGM results in the increase of

photoluminescence of about 7 and 3 in the unsaturated and saturated regimes, respectively. Finally, we demonstrated the coupling of V_B^- via two excitation configurations. Importantly, in a non-local configuration, the PL intensity and the ODMR signal collected from guided photons, indicating efficient coupling of V_B^- to TiO_2 ring resonators. Our results are promising for scaling up integration of layered materials with nanophotonic resonators.

Methods

Hybrid resonator fabrication

Following the hBN transfer step, a thin layer of e-beam polymer resist (CSAR, AllResist GmbH) was spin-coated onto the sample for 60 s at 5000 rpm followed by baking on a hotplate at 170 °C for 2 minutes. EBL patterning was performed in SEM (Zeiss Supra 55 VP) with electron energy of 30 keV, 20 pA current and a base dose of 100 $\mu C cm^{-2}$. The scanning beam was controlled by the Raith EBL system. After the development step, 50 nm Cr is deposited on the substrate using a magnetron sputtering machine. Afterwards, the residual polymer was removed in hot CSAR remover (AR600-71, AllResist GmbH). The patterns were transferred into the underlying hBN/ TiO_2 /Si sample using ICP/RIE technique. A mixture of SF_6/H_2 as reactive gases were introduced into the ICP/RIE chamber with a ratio of 1:7 and then plasma was generated by RF power of 100 W. In the following step, the sample was immersed into a 10% KOH aqueous solution for continually 5 minutes and then placed into a beaker of water to stop basic reactions. After the undercut step, the Cr metal mask was stripped away using Cr etchant. The sample was then rinsed with IPA and water followed by annealing at 300 °C to clean the etchant and increase adhesion.

Ion implantation

The creation of boron vacancy defects is achieved by focused ion beam irradiation in a Helios G4 PFIB UXe DualBeam

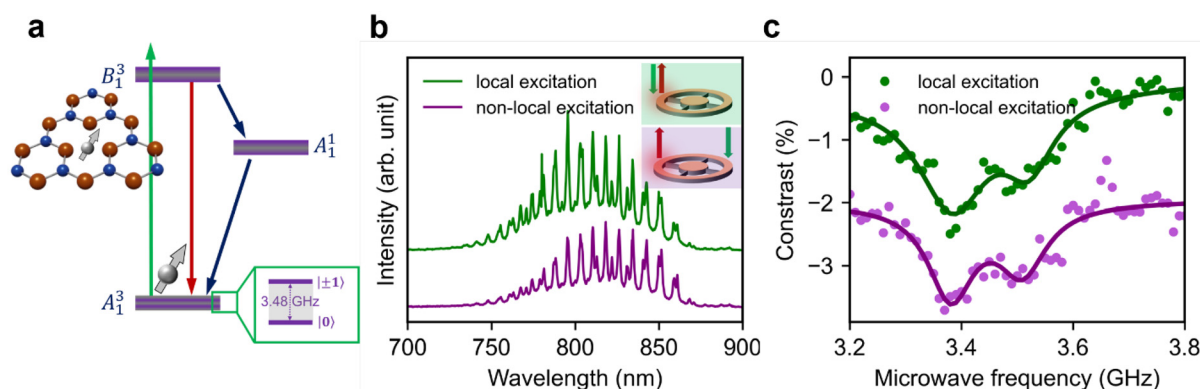


Fig. 3 ODMR measurement of coupled V_B^- . (a) Schematic of the V_B^- defect and an energy diagram showing the main optical pumping cycle and the alternate cycle through the metastable state. (b) PL spectrum from coupled V_B^- in local and non-local configurations. The spectra were offset in Y-axis for clarity. The inset schematically shows these configurations. (c) ODMR measurement from coupled V_B^- in local and non-local configurations. The microwave power was set to 10 dB for both configurations. The ODMR contrast of the non-local excitation scheme was offset for clarity.

microscope. Ion irradiation is performed at 60° incidence angle with respect to the surface normal to maximize the number of defects in a thin flake. A N₂ source is used, the beam energy and current are 5 kV and 75 pA respectively. A square irradiation pattern is defined over the resonator structure containing the hBN flake. The irradiation area and time are set to achieve an ion fluence of 1×10^{14} .

FDTD simulations

The FDTD was used to calculate the WGMs of a TiO₂ ring resonator using commercial software (Lumerical FDTD). The TiO₂ ring resonator with four arms clamping on the central disk was embedded in vacuum. All dimension parameters of the whole structure and the refractive index of TiO₂ were taken from the experiment. TE/TM WGMs are excited with an in-plane electric/magnetic dipole lying on the ring avoiding the clamping points, respectively. The dipole orientation was perpendicular to the curvature of the ring. Perfectly Matched Layers (PML) were applied in all three directions. A time monitor was used to capture the decay of the field and convert the spectrum in frequency domain. The cut off wavelength of TM modes was around 1050 nm which was mainly controlled by the thickness of the ring resonator.

PL characterization

PL spectra were recorded using a lab-built confocal setup. The devices were excited with a 532 nm continuous wave laser collimated and directed using several mirrors and lenses. The laser was focused onto the sample by a 100× and 0.9 NA objective forming around 500 nm spot through a 4f scanning system. The laser was scanned over the sample by a scanning mirror and the signals were collected by the same objective and transmitted back to the detectors. The signals were filtered by a 568 nm long pass filter and sent to a spectrometer (Princeton Instruments) or an avalanche photodiode APD (Excelitas) by a flip mirror.

ODMR characterization

For the ODMR characterization, the samples were connected to a chip holder and a wire antenna (~30 μm diameter) was placed next to the structures within a few tens of micrometers. To generate microwave signals, the current was passed through the antenna by a RF generator (AnaPico APSIN) and amplified (minicircuits, ZHL-16W-43-S+). Microwave was swept over 3.2 to 3.8 GHz at -10 dbm and PL signals were collected for 10 ms while the microwave field was on and off. The spin transitions were obtained by fitting a Lorentzian function to the data which yield two resonance frequencies at ~3.4 and ~3.5 GHz. The ODMR contrast was measured from the difference between the recorded signals in each frequency value.

Conflicts of interest

There are no conflicts to declare.

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